

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): IWASAKI, et al.

Filed: November 6, 2001

For: SEMICONDUCTOR DEVICE WITH LAYERED
INTERCONNECT STRUCTURE

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

November 6, 2001

Sir:

Please amend the above-identified application, prior to examination thereof,
as follows:

IN THE SPECIFICATION

Page 1, between the title and the heading "BACKGROUND OF THE
INVENTION", please add the following new paragraph:

--This application is a Continuation application of application Serial No.

09/255,856, filed February 23, 1999, the contents of which are incorporated herein

by reference in their entirety.--